ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention

OPTIMUM PADSET FOR WIRE BONDING RF
TECHNOLOGIES WITH HIGH-Q INDUCTORS

Application Number:

Confirmation Number:

First Named Applicant:

Douglas Coolbaugh

Attorney Docket Number:

BUR920020119US1

Art Unit:

Examiner:

Search string:

(4845543 or 5139192 or 5773899 or 5884835 or 6027999 or 6027999 or 6077766

or 6218728 or 6306750).pn

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
BS	1	4845543	1989-07-04	Okikawa et al			
	2	5139192	1992-08-18	Simmonds			
	3	5773899	1998-06-30	Zambrano			
	4	5884835	1999-06-23	Kajiwara et al			
	5	6027999	2000-02-22	Wong			
	6	6027999	2000-02-22	Wong			
	7	6077766	2000-06-20	Sebesta et al			
	8	6218728	2001-04-17	Kimura			
	9	6306750	2001-10-23	Huang et al			

Signature

Examiner Name	, , Date
124/	9/14/05

Form PTO-1449 U.S. DEPARTMENT OF COMMERCE (REV. 7-80)PATENT AND TRADEMARK OFFICE				Atty. Docket N . BUR920020119US1 (16763)		Serial No.			
LIST OF PRIOR ART CITED BY APPLICANT JAN 2 3 2004				Applicant Douglas D. Coolbaugh, et al					
(Use several sheets if necessary)				Filing Date	Group Unassigned				
U.S. PATENT DOCUMENTS									
EXAMINER INITIAL*		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (if appropriate)		
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		DOCUMENT NUMBER	DATE	COUNTR	r CLASS	SUBCLASS	TRANSLATION		
							YES	NO	
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OTHER PR	JOR A	RT (Including Author, Tit	·		<u> </u>	1 : 1 6 6		-4	
B S		S.G. Bombardier, et al. (1997) "Aluminum-Tungsten-Aluminum Sandwich for Semiconductor Chip Wirebond Pad", IBM Technical Disclosure Bulletin, Vol. 40, No. 6, page 131;							
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		IBM Technical Disclosure Bulletin, Vol. 36, No. 1, page 41; T.H. Chiles (1989) Abstract of Disclosure No. 30581 entitled "Use of a Composite Metal Pad for							
		Wirebond connection to the Copper Core of a Metal Core Substrate Circuit Board" Kenneth							
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V	ļ	Wire Bonding", Kenneth Mason Publications, Ltd. England, No. 342 (1 page).							
EXAMINER	DATE CONSIDERED 9/14/05								
* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.									